



**RESPONSE UNDER 37 C.F.R.
§1.116 EXPEDITED PROCEDURE
EXAMINING GROUP 1763**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yukio Morishige, et al.

Examiner: Richard R. Bueker

Serial No.: 10/600,075

Art Unit: 1763

Filed: June 20, 2003

Docket: 16748

For: LASER CVD DEVICE AND
LASER CVD METHOD

Dated: August 30, 2006

Confirmation No. 9161

Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.116

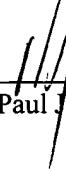
Sir:

In response to the Office Action of May 30, 2006, Applicants respectfully request entry of the following amendments under 37 C.F.R. § 1.116 that are believed to place the Application in condition of allowance.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, Box 1450, Alexandria, VA 22313-1450 on August 30, 2006.

Dated: August 30, 2006


Paul J. Esatto, Jr.